

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	:	Uzoh et al.
Appl. No.	:	10/698,878
Filed	:	October 31, 2003
For	:	METHODS AND DEPOSITING HIGH YIELD AND LOW DEFECT DENSITY CONDUCTIVE FILMS IN DAMASCENE STRUCTURES
Examiner	:	Luan V. Van
Group Art Unit	:	1753
Confirmation No.	:	1999

RESPONSE TO OFFICE ACTION

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed on August 2, 2006, please amend the above-captioned application as set forth herein. A one-month extension of time is hereby requested.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.